

## Preparation and Characterization of Co Doped Copper Oxide (II) Thin Films by 45° Angle Chemical Spraying Pyrolysis

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### Abstract

In this work, Co doped copper oxide (II) thin films (COTF) were deposited by chemical spray pyrolysis method. Structural analyses have confirmed monoclinic polycrystalline for COTF deposited at 400 °C substrate temperature. Compared with pure COTF, Co-doped samples showed larger grain size with distortion in the structure. With the increase of doping concentration the structure changes to amorphous. Bandgap energy was 2.45 eV before doping and 2.6 eV at 3% doping and began to decrease with increasing doping concentration. Activation energy was found to be 0.24 eV and it decrease with increase of doping. The Co (6%) doped –COTF are deposited on silicon substrate to fabricate CuO-Si hetero-junction.

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### 1. Introduction

CuO is a one among important monoclinic III-V compounds and interesting transitional metal oxide semiconductor showing p-type conductivity [1]. CuO is used because of its non-toxic nature, and its constituents are available in Earth [2]. COTF were deposited by several methods, such as anodization method [3], Spray Pyrolysis [4], Spin coating technique [5], Sol-Gel technique [6], and Chemical bath deposition method [7].

Researchers have studied the improvement of the properties of CuO with several mechanisms, including the treatment of heat (annealing) [8], and doping with other elements to improve their characteristics. Dopants such as Lithium (Li) [9, 10, 11], Manganese (Mn) [12, 13], Zirconium (Zr) [14], and Iron (Fe) [7] used to improve the device properties for several applications.

Cobalt is already used as a dopant in COTF by many researchers recently [15, 16, 17] due to: (a) similarity in ionic radii between Co (0.082 nm) and Cu (0.096 nm) [18], (b) it's reported to be one among the primary nonprecious metal catalyst with properties quite almost similar to that of platinum [15].

Copper oxide thin films doped with cobalt are prepared in several methods: flame spray pyrolysis [19], precipitation method [20], spin coating technique [5], and sputtering technique [16] and successive ionic layer adsorption and reaction method [21].

In this work, we prepared Co- doped CuO thin film by spray pyrolysis, using different concentration 3%, 6%, and 9% of doping Co. Precise examination of structural and optical properties of Co doped CuO films, and electrical

properties has been also implemented. The aim of this work is to increase the conductivity of CuO thin films by doping, which can be used as a device in solar cells applications. Our 45° angle deposition using low cost spray pyrolysis technique can provide smooth thin films with fewer defects which can enhance the performance of CuO thin film solar cells.

### 2. Experimental

COTF doped with Co (3%, 6%, and 9%) were deposited by spray pyrolysis method on glass substrate. Pure Cu (NO<sub>3</sub>)<sub>2</sub>·3H<sub>2</sub>O and Co (NO<sub>3</sub>)<sub>2</sub>·6H<sub>2</sub>O from PHD company were prepared in volumetric ratios by preparing the same concentration of copper nitrate and cobalt nitrate 0.1 M and dissolved in distilled water. The solutions are sprayed diagonally at 45°, for 3 s spraying time in 30 s stopping time (the time between two deposition batches). The substrates; glass and Si wafers are rotated on a hot plate with 0.12 ml/sec deposition rate at 400 °C temperature. The (XRD) equipment utilizes Cu-K $\alpha$  radiation ( $\lambda=0.15418$  nm) (8 deg/min) and theta range (10-80 deg). Atomic Force Microscope (AA2000 Atomic Force Microscope AFM) has been utilized to analyze the surface topography of the films. The morphology of the film and the film thickness by cross section (FESEM) was obtained. The energy band gap  $E_g$  and absorption coefficients were determined by UV-Vis spectrophotometer using wavelength range (400-1100 nm). The dc-electrical properties of the films were analyzed by Hall measurement system using an applied magnetic field (0.25 T) and a current in the range (0-40  $\mu$ A). These measurements are

used to determine the type of charge carriers, the conductivity and the mobility of the material. Activation Energy  $E_a$  has been studied by a homemade Seebeck system.

### 3. Results and Discussion

#### Structural properties

The XRD patterns of the pure and Co-doped of all examples are presented in Figure (1). The peaks, indexed as (002) and (111) are located at 35.6 and 38.6 2theta which correspond to (002), and (111) planes of CuO, respectively. The intensity of the (111) peak increases at doping ratio of 3%. The intensity of the (002) indexed peak decreases with the increase of doping with cobalt indicating that structural changes occur such that degree of crystallinity decreases with the doping increased. The structures of the un-doped sample have been assigned to be monoclinic polycrystalline structure. In general, the amorphous nature of the material leads to the hump-like feature in the XRD pattern. In the present work, the crystalline film was deposited on an amorphous glass substrate. The hump-like feature, observed in the XRD pattern, is believed to be due to the x-ray being diffracted by the substrate. The intensity of the XRD pattern is limited such that the (002) peak decreases and becomes hard to be observed with the increase of doping with cobalt.

The decrease of crystallinity with the increase in doping was reported for CuO thin films doped with zinc [4]. The grain size  $D$  values are (6.5, 7.8, 13.05 and 13.04 nm) for un-doped, 3%-, 6%- and 9%-doped thin films with Co respectively. The crystal size ( $D$ ) increases with the increase in Co-doping of the CuO film. This is attributed to the ionic mobility and radius of cobalt ions (58.93 Å). In addition, due to the low activation energy, these ions transfer from trap sites to nucleation sites during the crystal growth process leading to increase in crystal size [5, 18]. Increasing of doping up to 3% leads to increases the grain size dramatically and suddenly result-in a distortion of the structure. These results have good agreement with FESEM images as they will be displayed later on. The conductivity of Co doped increase significantly at 9%.

The grain size of Co doped CuO thin films was determined by estimating the full peak width at half maximum (FWHM) of (111) utilizing the Scherrer's condition [22].

$$D = \frac{0.94 \lambda}{\beta \cos \theta} \quad (1)$$

where  $\lambda$  is the wavelength (0.15418 nm),  $\theta$  is the Bragg diffraction angle,  $\beta$  is the FWHM.

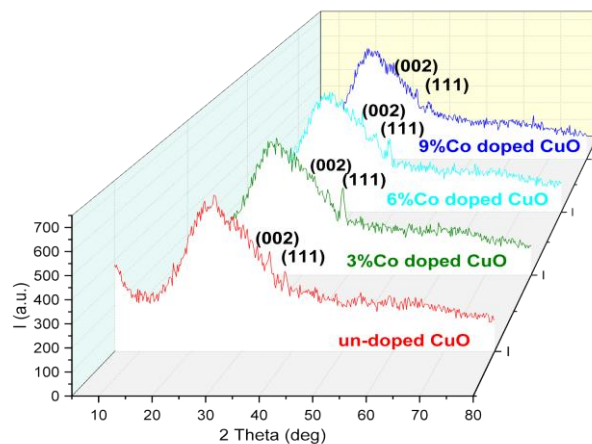
Bragg's law is used to determine the lattice spacing ( $d$ ) for all the COTF [22]:

$$2d \sin \theta = n\lambda \quad (2)$$

where  $n=1$  is the principle diffraction order. The dislocation density of defects ( $\delta$ ) in the CuO films was determined utilizing the following equation [23]:

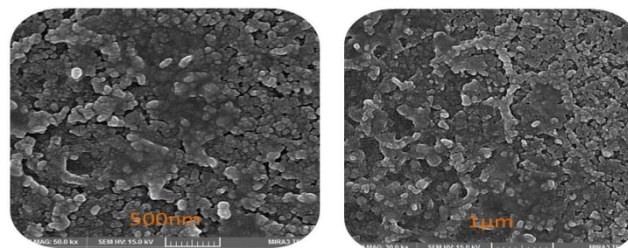
$$\delta = \frac{1}{d^2} \quad (3)$$

The dislocation density in the CuO structure decrease for Co doping at 3% Co (from  $2.3 \times 10^{12}$  to  $0.58 \times 10^{12} \text{ cm}^{-2}$ ) corresponding to more regular crystalline structure at 6%, where the dislocation density has been decreased because the grain size of film was increase with doping which means that the number of defects in the CuO films has been decreased with the doping. These results coincide with those of reference [16].



**Figure 1.** The X-ray diffraction (XRD) CuO Doping (3%, 6%, 9% Co).

FESEM images with scale bar  $1 \mu$  and 500 nm for pure and doped 3%, 6% and 9% COTF are shown in Figures 2 (a-d). The doping of CuO thin films with Co affected the homogeneity of the films, where the homogeneity of these films decreases with an increase in the proportion of the Co, the reason may be due to an increase in the grain size as shown in Table 2. It is also noticed that with the increase of doping the nanostructures in the thin film increase due to possible transfer of Co ions to nucleation sites [4]. This is expected to result into enhancement of mobility of charge carriers due to increase of charge carriers concentration at the nucleation sites.



**Figure 2(a).** FESEM image for CuO un-doped.

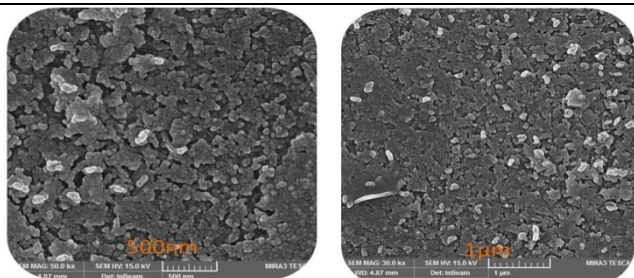


Figure 2(b). FESEM image for CuO doping 3% Co.

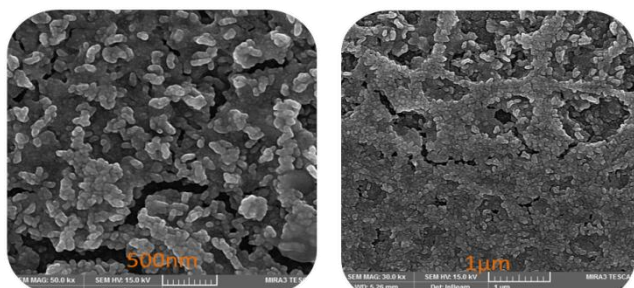


Figure 2(c). FESEM image for CuO doping 6% Co.

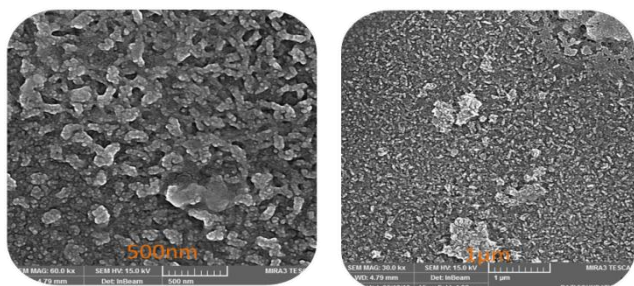


Figure 2(d). FESEM image for CuO doping 9% Co.

Topography of the films is presented by AFM 3D images in Figures 3 (a-d). In general, the particle size has a similar performance to the crystallite size. Average Roughness decrease with the increase of Co doped CuO and increases at 9%, as shown in Table 1. And these results will good aggregates with FESEM images.

Table 1. AFM parameters of CuO un-doped and Co doped.

Samples	Roughness average nm	Root mean square RMS nm
CuO- pure	4.51	5.82
3% Co	4.38	5.67
6% Co	4.18	5.36
9% Co	4.3	5.51

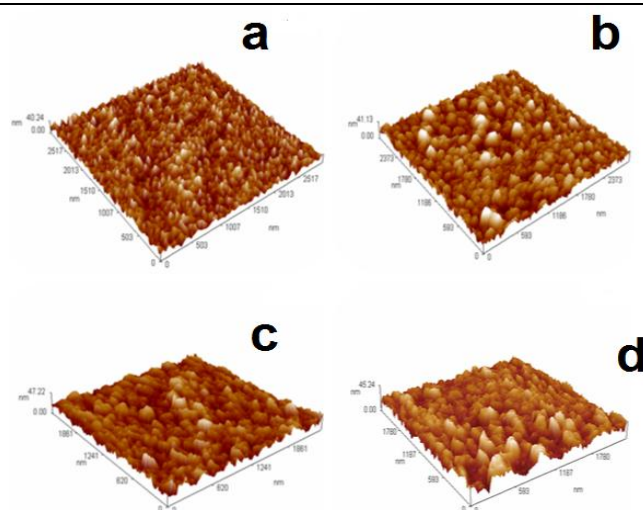


Figure 3. AFM 3-D image for (a) CuO pure, (b) CuO doping 3% Co, (c) CuO doping 6% Co, and (d) CuO doping 9% Co.

### Optical properties

In Figures 4 (a-d), the values of direct energy gaps ( $E_g$ ) are determined from the intercepts of the least square fits with the x-axes. The optical band gaps were (2.45, 2.6, 2.55 and 2.5eV) for un-doped, 3%, 6% and 9% Co doping CuO, respectively. In particular,  $E_g$  had a relatively high value at doping concentration of 3% Co. This may be due to enhanced crystallization of the CuO deposited films as indicated by the XRD pattern (Figure 1). However,  $E_g$  decreased at doping concentrations 6% and 9% Co and this may be due to high number of defects in the structure at this high doping concentration. This behavior agrees well with that in reference [17].

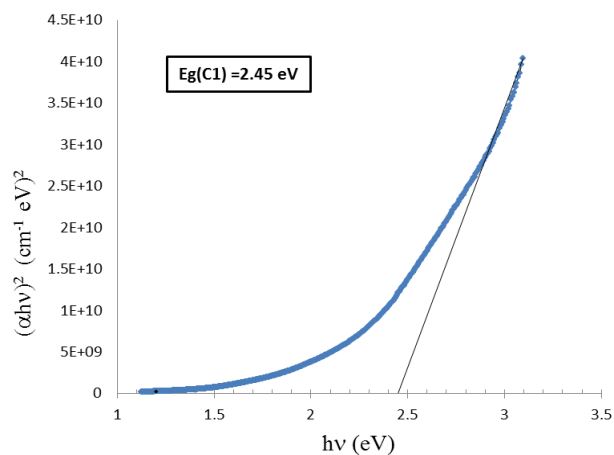
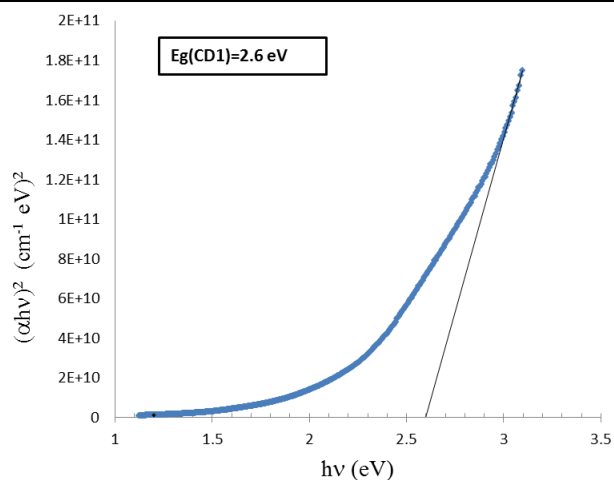
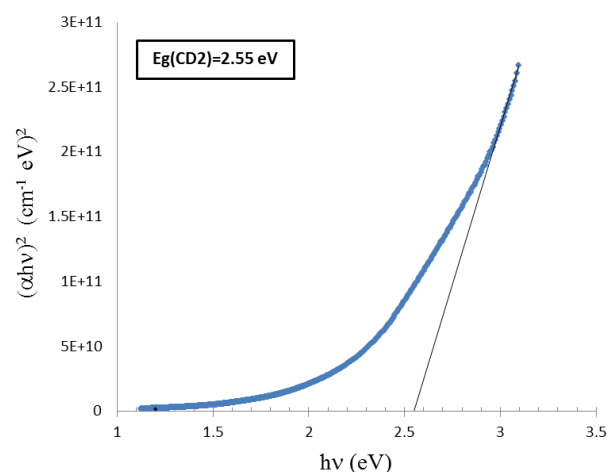


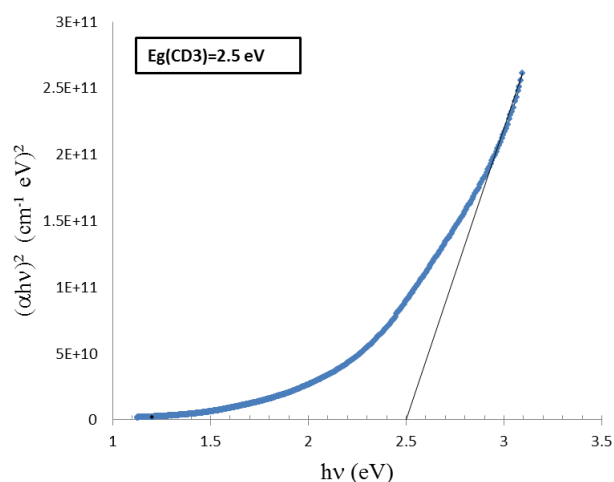
Figure 4(a). Energy bandgap for CuO thin film (C1) un-doped.



**Figure 4(b).** Energy bandgap for CuO thin film doping with (CD1) 3%.



**Figure 4(c).** Energy bandgap for CuO thin film doping with (CD2) 6%.



**Figure 4(d).** Energy bandgap for CuO thin film doping with (CD3) 9% Co.

The energy values of Urbach, which is the energy of extra levels (tails levels), are associated with the XRD characteristics are recorded in Table 2. The estimations of  $E_u$  are discovered increment, while the increase in grain size and decrease in dislocation density means an increase in the energy of the additional level  $E_u$ .

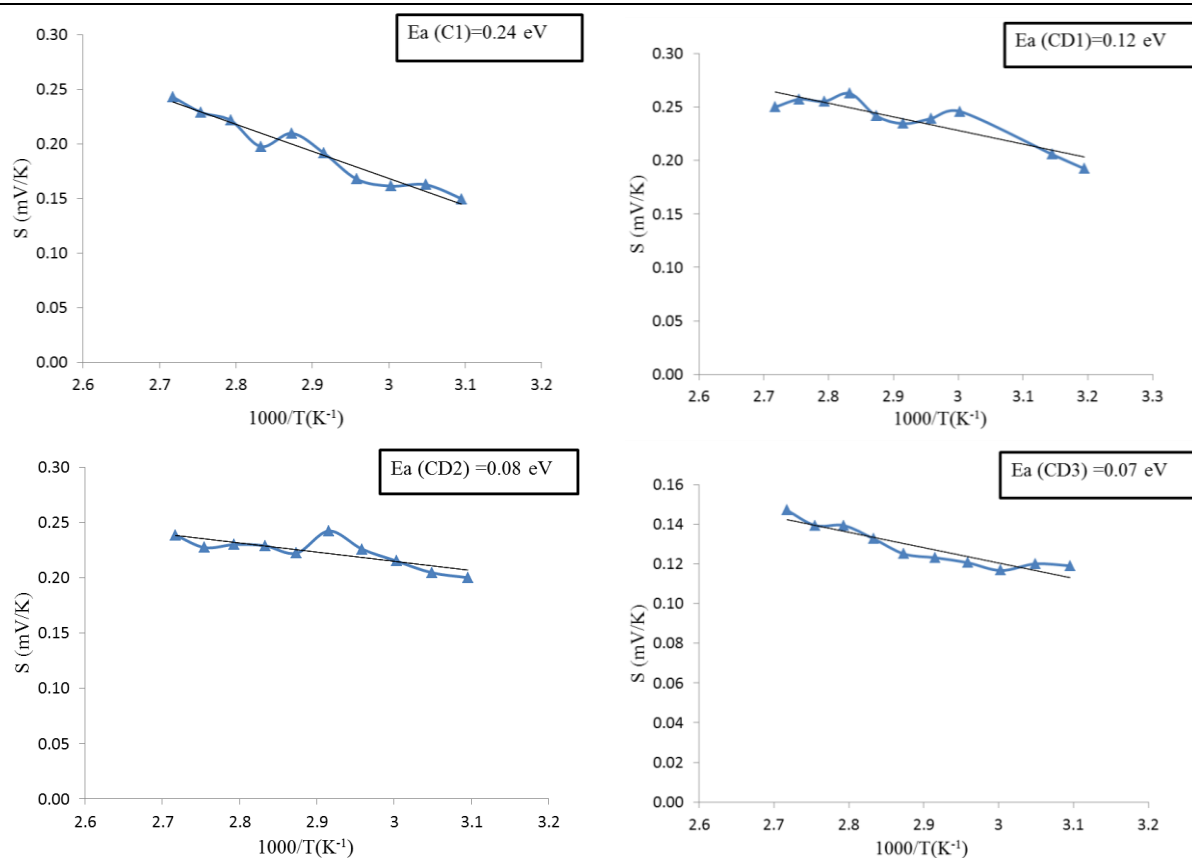
**Table 2.** XRD parameters calculated grain size and Dislocation density assorted with Urbach energy.

Sample	$E_u$ (eV)	Grain size (D)nm	Dislocation density ( $\delta$ ) $\text{cm}^{-2} \times 10^{12}$	Activation energy $E_a$ (eV)
CuO-pure	1.04	6.5	2.3	0.24
CuO doping 3% Co	1.08	7.8	1.6	0.12
CuO doping 6% Co	1.13	13.05	0.58	0.08
CuO doping 9% Co	1.25	13.04	0.58	0.07

Relatively low bandgap (high blackness) for Co-doped CuO is relevant to optoelectronic devices, for example, solar cell and photodiode.

#### Electrical properties

Activation energy  $E_a$  for Co-doped COTF are presented in Table 2. Due to doping,  $E_a$  decreases 0.24 to 0.07 eV. Fig. 5 shows a plot between  $1000/T$  and Seeback coefficient. Decreasing of  $E_a$  with doping is confirmed by Urbach energy  $E_u$  values. Similar behavior is reported in [21].



**Figure 5.** Activation energy for CuO pure(C1) and doping with 3%(CD1), 6%(CD2), and 9%(CD3) Co.

Hall effect measurements is used to calculate carrier density, mobility and conductivity which are listed in Table 3. Increasing of CuO conductivity at 9% doping of Co, due to degradation of CuO Structure.

**Table 3.** The results of Hall Effect for un-doped and Co- doped COTF.

Sample	Carrier concentration $\text{cm}^{-3}$	Mobility ( $\text{cm}^2 \text{V}^{-1} \text{s}^{-1}$ )	Conductivity ( $\Omega \text{cm}^{-1}$ )	Type of CuO
CuO-pure	$7.4 \times 10^{17}$	1.005	0.119	p-type
CuO doping 3% Co	$6.3 \times 10^{17}$	1.002	0.101	p-type
CuO doping 6% Co	$1.1 \times 10^{18}$	1.072	0.189	p-type
CuO doping 9% Co	$2.2 \times 10^{18}$	1.052	0.370	p-type

#### 4. Conclusions

In summary, Co-doped and un-doped COTF were successfully prepared by using spray pyrolysis method. XRD showed monoclinic polycrystalline. However, Co-doped samples showed larger grain size with distortion in the structure. With increasing of doping concentration the structure changes to amorphous. The grain size increases for doping concentration larger than 3%. Bandgap energy of the samples decreases with doping concentration 6%. Un-doped and Co doped CuO have p-type conductivity. Increasing of conductivity of CuO thin films after Co doped gives importance to the CuO in solar cell applications.

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